

## **Z-COAT 100**

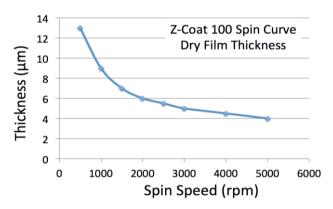
# Wafer Surface/Bump Protection Film (Water Soluble)

Z-Coat 100 is a spin-on coating designed for wafer surface and bump temporary protection in laser dicing/drilling and process handling. Z-Coat 100 can be easily removed with DI water at room temperature.

#### **Basic Material Property**

Z-COAT 100		
Appearance	Clear/Light Yellow	
Odor	Slight	
Viscosity	400~500 cps	
Solvent	Di-water with IPA	
Thermal	Stable Up to 280°C, Optical Clear to 200°C	
Coating	Spin Coating	
Package	Available in 1kg and 1 gallon bottle	
Storage	Room Temperature	

### **Spin Coating**



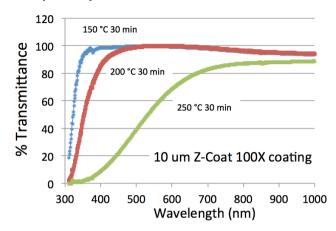
For laser dicing application, the recommended Z-Coat 100 thickness is  $< 5 \mu m$ .

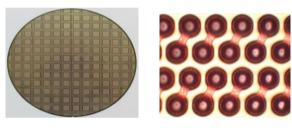
#### **Drying:**

Thickness	Recommended Dry Condition
< 5 μm	60 °C 5 minutes + 120°C 2 minutes
5 ~ 10 μm	60 °C 5 minutes + 120°C 5 minutes
> 10 μm	60 °C 5 minutes + 120°C 10 minutes

Slower than 500 rpm spin speed coating is NOT recommended.

#### **Transparency:**





Bumped wafer bumps under hi-mag 5 μm Z-Coat 100 on bumped wafer after dry

#### **Other Properties:**

Decomposition at 390 °C

Optically clear after 200 °C 30 minutes bake

No corrosion-Metal Safe-Environmental Friendly.

### Cleaning:

Z-Coat 100X can be easily removed with DI-water. For best cleaning result, use warm DI water (~70 °C) to rinse or soak, followed by spin dry.

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